

PATENT APPLICATION

IN THE U.S. PATENT AND TRADEMARK OFFICE

April 27, 2006

Applicant(s) : Chisato HOSHINO
For : THERMAL CONDUCTIVE SILICONE COMPOSITION

Serial No. : 10/567 587 Group: Unknown
Confirmation No.: Unknown
Filed : Unknown Examiner: Unknown
International Application No. : PCT/JP2004/014679
International Filing Date : September 29, 2004
Atty. Docket No.: 3400.P1429US

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the provisions of Rules 1.97(b)(2) and 1.98, enclosed herewith is Form PTO-1449 and the references cited thereon. Copies of cited U.S. references are not submitted in accordance with 37 CFR 1.98(a).

Further consideration is respectfully solicited.

Respectfully submitted,

TFC/jas


Terryence F. Chapman

FLYNN, THIEL, BOUTELL
& TANIS, P.C.
2026 Rambling Road
Kalamazoo, MI 49008-1631
Phone: (269) 381-1156
Fax: (269) 381-5465

Dale H. Thiel	Reg. No. 24 323
David G. Boutell	Reg. No. 25 072
Terryence F. Chapman	Reg. No. 32 549
Mark L. Maki	Reg. No. 36 589
Liane L. Churney	Reg. No. 40 694
Brian R. Tumm	Reg. No. 36 328
Steven R. Thiel	Reg. No. 53 685
Donald J. Wallace	Reg. No. 43 977
Kevin L. Pontius	Reg. No. 37 512
Sidney B. Williams, Jr.	Reg. No. 24 949

Encl: Form PTO-1449 and references cited thereon
Post Card

INFORMATION DISCLOSURE CITATION	Applicant: Chisato HOSHINO
	Ser.No.: 10/567 587 Filed: Unknown
	Conf. No.: Unknown Atty. Docket No.: 3400.P1429US
	Group: Unknown Date: April 27, 2006

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No.	Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant
	AA	US 5 246 703	09-21-1993	Durfee
	AB	US 5 420 189	05-30-1995	Kishita et al
	AC	US 6 005 131	12-21-1999	Jentsch et al
	AD	US 6 025 435	02-15-2000	Yamakawa et al

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No.	Country Code - Document Number - Kind Code	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Trans.
	AH	JP 51 55870	05-17-1976	Shinetsu Chem Ind. Co. Ltd.	Abstract
	AI	JP 64 49959	02-27-1989	Tokico Ltd.	Abstract
	AJ	JP 2 97559	04-10-1990	Toshiba Silicone Co. Ltd.	Abstract
	AK	JP 3 47841	2-28-1991	Toray Dow Corning Silicone Co. Ltd.	Abstract
	AL	JP 2623380	12-11-1992	Shin Etsu Chem Co. Ltd.	Abstract
	AM	JP 5 255359	10-05-1993	Dow Corning Corporation	US Equiv
	AN	JP 6-271773	09-27-1994		US Equiv
	AO	JP 6-329916	11-29-1994	Shin Etsu Chem Co. Ltd.	Abstract
	AP	JP 8-92371	04-09-1996	Shin Etsu Chem Co. Ltd.	Abstract
	AQ	JP 8-325457	12-10-1996		US Equiv
	AR	JP 9-25411	01-28-1997		
	AS	JP 9-208591	08-12-1997	Bayer Aktiengesells Chafft	US Equiv
	AT	JP 2000-1616	01-07-2000	Shin Etsu Chem Co. Ltd.	Abstract
	AU	JP 2000-256558	09-19-2000	Shin Etsu Chem Co. Ltd.	Abstract
	AV	JP 2000-327917	11-28-2000	Fuji Kobunshi Kogyo KK	Abstract
	AW	JP 2001-348483	12-18-2001	Dow Corning Toray Silicone Co. Ltd.	Abstract
	AX	JP 2003-213133	07-30-2003	Shin Etsu Chem Co. Ltd.	Abstract
	AY	JP 2004-122664	04-22-2004	Shin Etsu Chem Co. Ltd.	Abstract

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No.	(Include Author, Title, Date, Pages, Etc.)
	AZ	
EXAMINER SIGNATURE		DATE CONSIDERED

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.